# EIB **POWER SUPPLY FOR** FOCUSED ION BEAM



### ISO9001:2015



- Standard ET interface, RS-232 control Electron Microscopy, Electron Beam, Ion Beam Power System
- High Accuracy, High Stability, Low Ripple
- Integrated Single Chassis Solution
- Corona Free Operation
- Overvoltage, overcurrent, short circuit and Acr protection

### OEM customization available

### INTRODUCTION

**APPLICATION SPECIFIC** 

Wisman's EIB Series is an integrated multiple output high voltage power supply specifically designed for focused ion beam applications. An additional Lens Chassis is available, providing the high performance fixed or reversible polarity high voltage lenses required to focus the Ion Beam.Alloutputs are offered with ultra-low output ripple, excellent regulation, stability, temperature coefficient, drift and accuracy specifications. Isolation and control of the respective floating sources is provided via Wisman's proprietary high voltage isolation techniques. Customer control of this integrated EIB power supply system is accomplished via a fiber optic interface. All high voltage safety interlocks areof a failsafe hardware based design. Consult factory for final configuration requirements.

# **TYPICAL APPLICATION**

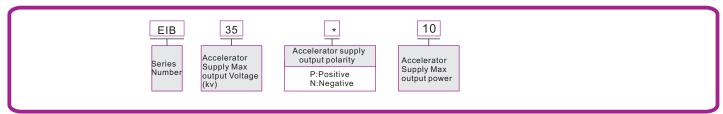
Scanning electron microscopy, Semiconductor analysis, Electron beam; Ion beam, Life science, Medical Chemical, Science experiment, Industry Application, Ion beam etching, Focused ion-beam lithography, Vacuum gun, **EIB SELECTION TABLE** 

Extractor Supply				Filament Supply				Suppressor Supply			
Voltage(kv	Current(uA)	Ripple	Stability	Voltage (v)	Current(A)	Ripple	Stability	Voltage(kv)	Current(uA)	Ripple	Stability
-15	400	<100mVp-p	500mv/10 hrs, after 2 hours' warm-up	5	5	10mAp-p	5mA/10min	±2	30	小于150mVp-p	500mv/10 hrs, after 2 hours' warm-up
16	1000	<160mVp-p	1. 6v/10 hrs, after 2 hours' warm-up	3.3	3	10mAp-p	5mA/10min	-1	150	小于20mVp-p	100mv/10 hrs, after 2 hours' warm-up

Accelerator Supply				LensA Supply				LensB Supply				
	Voltage(kv	Current(uA)	Ripple	Stability	Voltage(kv	Current(uA)	Ripple	Stability	Voltage(kv)	Current(uA)		Stability
	45	30	<200mVp-p	1.5v/10 hrs, after 2 hours' warm-up				1v/10 hrs, after 2 hours' warm-up	25	30	$\leq 1500000-0$	1v/10 hrs, after 2 hours' warm-up
	35	30	<200mVp-p	1.5v/10 hrs, after 2 hours' warm-up	30	30	100mVp-p	1v/10 hrs, after 2 hours' warm-up	30	30	<200mVp-p	1v/10 hrs, after 2 hours' warm-up
	-60	150	<600mVp-p	6v/10 hrs, after 2 hours' warm-up		Lens	(ontional)		ens(ont	ional)	1	

Lens	(optional)		Lens(optional)			
LensA	LensA LensB +30kV +25kV/-15kV		LensA	LensB		
+30kV			+/-30kV	+/-30kV		
-30kV +25kV/-15kV			+/-20kV	+/-30kV		

### **EIB SELECTION EXAMPLE**



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# SPECIFICTION ISO9001:2015

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	PARAMETER	DESCRIPTION						
	Input	105Vac~240Vac,47~63Hz; +24Vac,±5%@5.5A.						
	Output	Output Voltage 0~+45kv,output Current0~30uA,Referenced to Ground						
Ac	Load Regulation	$\pm 0.001\%$ (no load to rated load)						
Accelerator	Line Regulation	<100mA(Input Voltage change ±10%)						
	Ripple	Pls turn to EIB selection table						
	Temperature coefficient	25ppm/℃						
ř	Stability	1.5v/10 hrs after 2 hrs' warm-up						
	Output	Output Voltage0~+5vdc,output Current 0~5A,Referenced to Accelerator Supply						
	Load Regulation	±0. 1% (no load to rated load)						
Filament	Line Regulation	$\pm$ 0. 1% (no load to rated load) 5mA(Input Voltage change $\pm$ 10%)						
am	Temperature coefficient	<pre></pre>						
len	· .	Pls turn to EIB selection table						
-	Ripple	5mA/10mins after 2 hrs' warm-up						
	Stability Output	Output Voltage-2kV~+2kVdc,output Current 0~30uA,Referenced to Accelerator Supply						
Su	Load Regulation	$\pm 0.01\%$ (no load to rated load)						
uppress	Line Regulation							
re	Temperature coefficient	100mA(Input Voltage change ±10%)   25ppm/℃。						
SS	Ripple							
°,	Stability	PIs turn to EIB selection table 500mV/10hrs after 2 hours' warm-up						
		Output Voltage0V~-15kV,Output current 0~400uA,Referenced to Accelerator Voltage.						
Û	Output	$\pm 0.01\%$ (no load to rated load)						
tra	Load regulation	100mV (Input voltage change±10%)						
xtractor	Line regulation	Pls turn to EIB selection table						
9 9	Ripple							
	Temperature coefficient	25ppm/°C 500mV/10hrs after 2 hours' warm-up						
	Stability							
5	Output	Output Voltage0~-40KVdc,Output current 0~30uA,Referenced to Ground						
Lens	Load regulation	±0.01%(no load to rated load)						
As	Line regulation	100mV(Input Voltage change ±10%)						
	Ripple	PIs turn to EIB selection table						
	Temperature coefficient	25ppm/°C						
	Stability	1V/10 hrs after 2 hours's warm-up						
	Output	Output Voltage0v~+25KV,Output current 0~30uA,Referenced to Ground						
F	Load regulation	±0.005% (no Load to rated load)						
ens	Line regulation	100mV(Input Voltage change±10%)						
8	Ripple	Pls turn to EIB selection table						
	Temperature coefficient	25ppm/°C。						
	Stability	1V/10 hrs after 2 hours' warm-up						
S	Storage temperature	-30℃~+70℃。						
	Cooling	Natural convection						
	Humility	10%~90%RH,no condensing						
	Weight	20kg						





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# - APPLICATION SPECIFIC

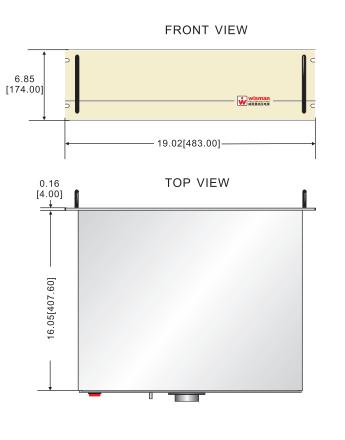
# RS-232 DIGITAL INTERFACE

J3	SIGNAL	J3	SIGNAL
1	N/C	6	N/C
2	TXD/Transmit	7	N/C
3	RXD/Receive	8	N/C
4	N/C	9	N/C
5	GND		

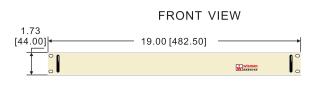
# ETHERNET DIGITAL INTERFACE

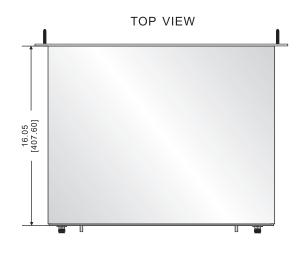
J5	SIGNAL	J5	SIGNAL
1	RX+ (Receive+)	6	TX-(Transmit-)
2	RX-(Receive-)	7	N/C
3	TX+(Transmit+)	8	N/C
4	N/C	9	N/C
5	GND		

### EIB DIMENSION



Unit:inch(mm)





BACK VIEW



